

Electronic Patent Application Fee Transmittal

Application Number:	10784697			
Filing Date:	23-Feb-2004			
Title of Invention:	Method and apparatus for low energy electron enhanced etching of substrates in an AC or DC plasma environment			
First Named Inventor/Applicant Name:	Kevin P. Martin			
Filer:	Scott A. Horstemeyer/Julie Campbell			
Attorney Docket Number:	62002-1752			
Filed as Small Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Filing a brief in support of an appeal	2402	1	250	250
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				250